

Application/Contr I No.	Applicant(s)/Patent under Reexamination	
10/800,549	RIBARICH ET AL.	
Examiner	Art Unit	
Y. J. Han	2838	

SEARCHED				
Class	Subclass	Date	Examiner	
323	225			
	242			
	247			
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363	25			
Search	updated	7/9/2006	/JH/	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
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